

AMENDMENTS TO THE CLAIMS

1 (canceled)

2 (canceled)

3 (original): A method for manufacturing metallic material
on which a chromium-oxide passivation film is formed, comprising
the step of:

forming the passivation film consisting of chromium oxide by
5 applying heat treatment in an oxidizing atmosphere after coating
chromium on the metallic material of the surface roughness (Ra)
of metallic material surface is not more than 1.5 μ m.

4 (original): A fluid supplying/exhaust system for
manufacturing semiconductors, comprising metallic material having
a chromium-oxide passivation film according to claim 1.